

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re application of | Docket No: Q85660 |
| Heiji WATANABE, et al. | |
| Appln. No.: 10/521,311 | Group Art Unit: 2815 |
| Confirmation No.: 1690 | Examiner: WARREN, MATTHEW E |
| Filed: January 14, 2005 | |
| For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND MANUFACTURING APPARATUS OF THE SAME | |

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicants hereby petition for an extension of time of one months, extending the time for responding to the Office Action of October 2, 2007 to February 2, 2008.

The statutory fee of \$120.00 is being submitted via EFS. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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Respectfully submitted,
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23373

CUSTOMER NUMBER

Date: February 4, 2008